## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Torbjörn Ling et al.	) Group Art Unit: 1791
Application No. 10/518,475	) Examiner: Luk, Emmanuel S.
Filed: December 20, 2004	) Confirmation No. 3599
For: MOLD FOR NANO IMPRINTING	)
Mail Stop Amendment	
Commissioner for Patents	
P.O. Box 1450	
Alexandria, VA 22313-1450	

## REQUEST FOR RECONSIDERATION

In reply to the Office Action mailed December 23, 2008, with a period for response extending through March 23, 2009, Applicants request the Examiner's reconsideration in view of the remarks that follow:

Remarks begin on page 2 of this paper.

Sir: